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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Arpan P. Mahorowala et al.

Serial No.: 09/902,728

Filed: July 12, 2001

Examiner: Barreca, Nicole M.

Art Unit: 1756

Atty Docket: YOR920000789US1

OFFICIAL

For: METHOD TO PREVENT  
PATTERN COLLAPSE IN  
FEATURES ETCHED IN SULFUR  
DIOXIDE-CONTAINING PLASMAS**RESPONSE AND AMENDMENT UNDER 37 CFR § 1.111**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Applicants submit the following Amendment and Remarks in response to the Office  
Action dated October 27, 2003.

#14,910  
Amendments to the Claims

this paper; and

Claims that begins on page 2 of

Remarks/Arguments begin on ~~page 3~~ of this paper.

The Applicants further submit a Declaration under 37 CFR 1.131, attached on a  
separate sheet.